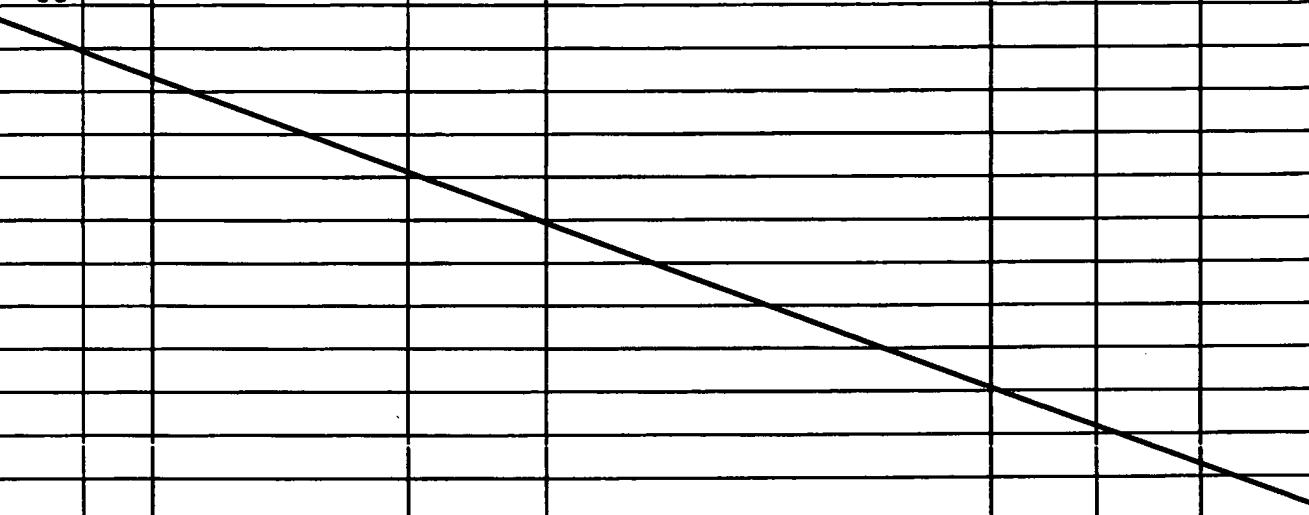
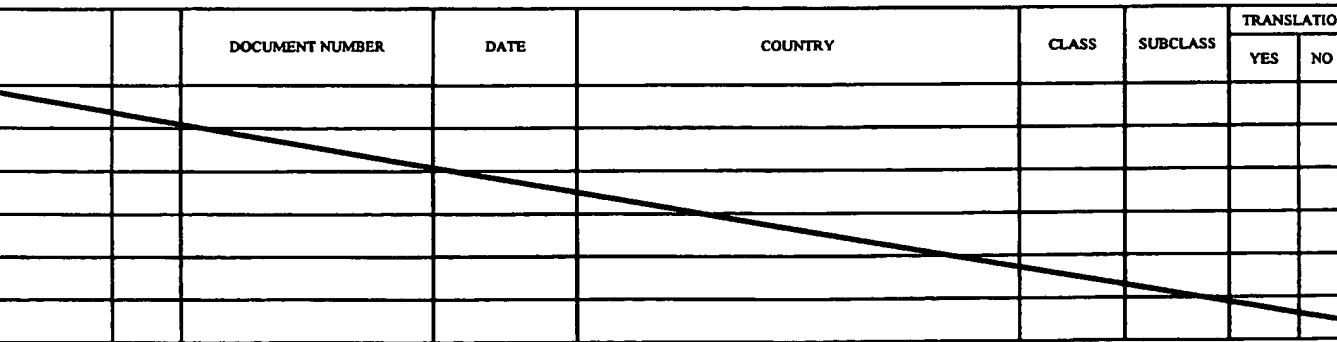
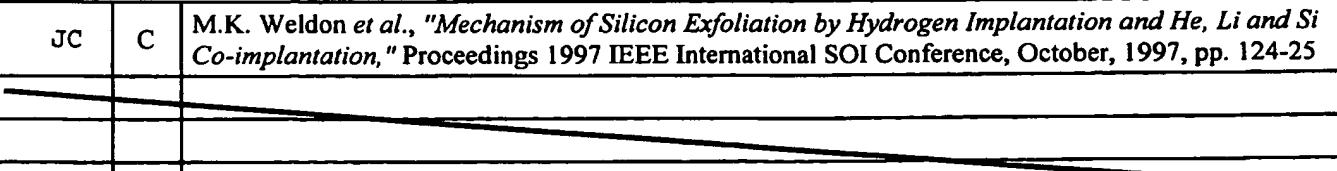


LIST OF REFERENCES CITED BY APPLICANT Form PTO-1449 (Use several sheets if necessary)					ATTY. DOCKET NO.: 4717-5700	APPLICATION NO.: 10/619,596
NOV 06 2003 Sheet 1 of 1					APPLICANT: Christophe MALEVILLE	
					FILING DATE: 16 July 2003	GROUP: 2813
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	CITE NO.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS
JC	A	6,429,104	08/2002	Auberton-Herve	438	527
JC	B	5,374,564	12/1994	Bruel	437	24
						
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)						
JC	C	M.K. Weldon et al., "Mechanism of Silicon Exfoliation by Hydrogen Implantation and He, Li and Si Co-implantation," Proceedings 1997 IEEE International SOI Conference, October, 1997, pp. 124-25				
						
EXAMINER /Jack Chen/ (08/18/2006)				DATE CONSIDERED		08/18/2006

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					APPLICANT: Christophe MALEVILLE			
					FILING DATE: July 16, 2003	GROUP: 2812		
Sheet 1 of 1								
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	CITE NO.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
JC	AA	6,664,169	12/2003	Iwasaki et al.	438	409		
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
JC	AB	10093122	10/1998	JP (with English Abstract)			YES	NO
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)								
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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